

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: S. KADLEC, et al.

Serial No.: 10/798,331

Filed: March 12, 2004

For: METHOD FOR MANUFACTURING SPUTTER-COATED  
SUBSTRATES, MAGNETRON SOURCE AND SPUTTERING  
CHAMBER WITH SUCH SOURCE

Group: 1753

Examiner: Michael A. Band

Conf. No.: 6134

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

December 6, 2007

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within the first month subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed August 6, 2007. A credit card payment form in the amount of \$120.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (635.43483X00) and excess fees credited to account.

Respectfully submitted,

/Ronald J. Shore/

Ronald J. Shore

Registration No. 28,577

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RJS/kmh  
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